

# Electron and ion beam dynamics in the CARIBU EBIS charge breeder

12<sup>th</sup> International Conference on Heavy Ion Accelerator Technology

June 18-21, 2012

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# Outline

- CARIBU EBIS charge breeder
- Goals of beam dynamics studies
- Simulation software
- Simulation results
  - Electron beam
  - Electron beam ion beam interactions
- Summary

# **CARIBU EBIS charge breeder**



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#### Design parameters

Parameter	Electron gun	
Parameter	High current	Low current
Maximum current	2 A	0.2 A
Nominal trap solenoid magnetic field	6 T	
Trap length	700 mm	
Trap current density	500 A/cm <sup>2</sup>	
Electron beam energy (gun/trap)	10/4–5 keV	7.7/1.2–2 keV
Cathode diameter	4 mm	1.6 mm
Drift tube diameters	20 mm	

# Goals

- Electron beam simulations
  - Determine the magnetic field at the cathode surface needed to avoid reflections
  - Ensure the design objectives (I=2 A, J>500 A/cm<sup>2</sup>) can be met
  - Establish design parameters for the collector
  - Establish an electric field for ion injection and extraction simulations
- Electron beam ion beam interactions
  - Establish the acceptance for injected ions
  - Establish ion beam parameters for the extracted beam

# Simulation Software

- TriComp
  - Calculates 2-d planar or axisymmetric electrostatic and magneto static fields from actual component cross sections
  - Numerically solves the Poisson equation for charged particles moving in the static fields
  - Accounts for the space charge of the electron beam
- Longitudinal symmetry of the EBIS allowed simulations to be separated into two regions
  - Gun-to-trap
  - Trap-to-collector

# **Gun-to-trap simulations**

 The specifics of the gun design were established by the manufacturers at the Budker Institute of Nuclear Physics (BINP), Novosibirsk, Russia



# **Gun-to-trap simulations**

- Minimum cathode surface magnetic field, B<sub>c</sub>, required
  - 0.15 T
- Contribution from 6 T main solenoid
  - 0.03 T
- Maximum electron gun coil performance
  - 0.16 T
- Beam parameters within the trap for high current electron gun and B<sub>c</sub>=0.15 T
  - $r_{e,t} = 0.316 \text{ mm}$
  - J = 636 A/cm<sup>2</sup>

# **Trap-to-collector simulations**

Simulation result showing electron trajectories, EBIS components, and electric potential distribution



# **Electron Distributions in the Collector**

For constant extractor potential, -9kV



# **Electric Field Solutions**

 Solutions to electron trajectory simulations resulted in electric fields which accounted for the electron beam space charge



Potential, radially from axis to entrance of collector

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# lon Optics in the EBIS

 Acceptance was determined by injecting ions into the EBIS fields from a plane within the collector



- Tracking the injected ions all the way to the center of the trap came at a price
  - Mesh elements for the field regions >~2 T needed to be 5-10x smaller to accurately represent the electron beam electric field
  - Time steps between consecutive trajectory calculations needed to be 10-100x shorter to correctly track the ions
- These type of simulations were possible and a few were performed as a baseline . . .
- But at ~1.5 hrs per run a more efficient method was used for the bulk of the calculations

 Instead of tracking to the trap center, the injection simulations were stopped 250 mm from the maximum magnetic field (6 T) region



15

# **Acceptance Criterion**

 $\mathcal{E}_{i,t} = \mathcal{E}_{i,s}$ 

- Ion beam radius = e-beam radius in trap;  $r_{i,t} = r_{e,t}$
- r<sub>i,s</sub> the ion beam radius at the end of the simulation which corresponds to r<sub>i,t</sub> = r<sub>e,t</sub>

$$\varepsilon = 2r \left(\frac{k_B T_{\perp}}{mc^2}\right)^{1/2}$$

$$r_{i,s} = r_{i,t} \sqrt{\frac{T_{\perp t}}{T_{\perp s}}}$$

$$\frac{T_{\perp t}}{T_{\perp s}} = \frac{\Delta U_{i,t}}{\Delta U_{i,s}} \quad \Delta U_i - \text{potential well within the radius of the ion beam}$$

#### \*Adapted from work by A. Pikin

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 Cutoff radius, r<sub>i,s</sub>, outside the trap could be calculated given electron beam parameters

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 Ion radii at the end for the injection simulations were compared to the r<sub>i.s</sub>



# Acceptance Comparison

 Comparing the results from the emittance conservation method (B<sub>max</sub>=2 T) and the full tracking method (B<sub>max</sub>=6 T)

r <sub>e,t</sub> (mm)	l <sub>e</sub> (A)	B <sub>t</sub> (T)	A* <sub>full</sub> (π·mm·mrad)	
			emit cons	full
0.316	2	6	0.0233	0.0222
0.283	2	6	0.0201	0.0201



Acceptance was calculated for wide range of conditions



 The calculated phase space volume can be used for beam matching from the ion beam transport line



# Extraction

- Determining the extracted beam emittance
- Analytically
  - Magnetic contribution

$$\varepsilon_m^* = \frac{2\pi e q B r^2}{4mc} \cdot 10^6 \left[\pi \cdot mm \cdot mrad\right]$$

- Electric contribution

$$\varepsilon_{e}^{*} = 2r \left(\frac{k_{B}T_{\perp}}{mc^{2}}\right)^{\frac{1}{2}} \cdot 10^{6} \left[\pi \cdot mm \cdot mrad\right]$$

– Upper limit for the extracted beam emittance for  $^{133}\mathrm{Cs}^{+20}$ 

$$\varepsilon_{tot}^* \approx 0.2 \left[ \pi \cdot mm \cdot mrad \right]$$

- BNL results from Test EBIS
  - 0.8-1.0  $\pi$ ·mm·mrad for 1-3 mA of Au<sup>32+</sup>

# Extraction

- Emittance conservation method but assuming r<sub>i,t</sub> = 1.5\*r<sub>e,t</sub>
- Ion beam radius can be calculated along electron beam
- Ion beam transported within electric field of electron beam simulation solution



# Summary

- Required magnetic field at the cathode surface is 0.15 T, within operating range of gun coil
- The electron beam can be adequately transported to achieve the design goals (I=2 A, J>500 A/cm<sup>2</sup>)
- The electron beam power can be safely dumped within the collector
- The acceptance of the EBIS has been determined for a wide range of operating parameters
- Acceptance and extraction simulations facilitate beam matching for the transport lines